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IN THE IS ITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KONISHI, et al.

APR 1 3 2007

Serial No.: 10/812,102

Filed: March 30, 2004

For: Substrate Processing Method and Apparatus

Art Unit: 1765

Examiner: Alanko, Anita Karen

Atty. Dckt: 033082M201

RESPONSE UNDER 37 C.F.R. § 1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Mail Stop: Amendment

Dear Sir:

This is in response to the Office action mailed January 16, 2007, to which the time for response is set to expire April 16, 2007. Claims 9-17 were withdrawn from consideration and claims 18-23 were rejected. Reconsideration and entry of the following amendment(s) are respectfully requested.

Amendment to the Claims begins on page 2 of this paper. Remarks begin on page 4 of this paper.